



**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## In re Application of:

Donald L. Yates

Serial No.: 10/027,951

Filed: December 19, 2001

**For:** METHOD OF REDUCING WATER SPOTTING AND OXIDE GROWTH ON A SEMICONDUCTOR STRUCTURE

Examiner: A. Markoff

**Group Art Unit: 1746** 

Attorney Docket No.: 2269-3375.6US

(95-0999.05/US)

## CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

June 8, 2004

Deidra Pfeil

Name (Type/Print)

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This amendment is in response to the Office Action of March 19, 2004 whose initial period of response is set to expire on June 19, 2004.

The listing of claims begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.